Attorney's Docke...o.: 12732-061001 / US5111

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Taketomi ASAMI et al.

Art Unit : Unknown

Serial No.: Unassigned

Examiner: Unknown

Filed

: August 1, 2001

Title

: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE

**SAME** 

Commissioner for Patents Washington, D.C. 20231

## TRANSMITTAL OF PRIORITY DOCUMENT UNDER 35 USC §119

Applicants hereby confirm their claim of priority under 35 USC §119 from the following application:

## Japan Application No. 2000-234913 filed August 2, 2000

A certified copy of the application from which priority is claimed is submitted herewith.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: August 1, 2001

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## 日本国特許庁 JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office

。出願年月日 ○Date of Application:

2000年 8月 2日

出 願 番 号 Application Number:

特願2000-234913

出 願 人 .pplicant(s):

株式会社半導体エネルギー研究所

2001年 6月12日

特 許 庁 長 官 Commissioner, Japan Patent Office 及川耕



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